S	earch	Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/824,577	LIU ET AL.	
Examiner	Art Unit	
Pamela E. Perkins	2822	•

SEARCHED			
Class	Subclass	Date	Examiner
438	210 239 467 600	3/19/2006	PEP

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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SEARCH N (INCLUDING SEARC)
	DATE	EXMR
EAST text search PALM inventor search	3/19/2006	PEP
EAST text search - "silicon residue"	1/7/2007	PEP